

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of: Ismail EMESH et al. Group Art Unit: 3723

Serial No.: 10/729,119 Examiner: Shakeri, Hadi

Filed: December 4, 2003 Confirmation No.: 3177

For: LUBRICANT FOR WAFER POLISHING USING A FIXED
ABRASIVE PAD

Attorney Docket No.: 004.0122

RESPONSE AND AMENDMENT

MAIL STOP AMENDMENT

Commissioner of Patents

P.O. Box 1450

Alexandria, VA 22313-1450

Sir:

This paper is responsive to the non-final Office Action mailed on August 25, 2006.
Please amend the above-identified application as set forth below.

Amendments to the Claims begin on page 2 of this paper.

Remarks/Arguments begin on page 8 of this paper.